

## Search History

| <u>Set Name</u>  | <u>Query</u>  | <u>Hit Count</u> | <u>Set Name</u> |
|--|---|------------------|-----------------|
| side by side   |   |                  | result set      |
| <i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i> |   |                  |                 |
| <u>L17</u>   | L16 and @pd<20030331  | 0                | <u>L17</u>      |
| <u>L16</u>   | L15 and l13   | 4                | <u>L16</u>      |
| <u>L15</u>   | (metal or wire or wiring) (layer or film) near7 l2  | 4244             | <u>L15</u>      |
| <u>L14</u>   | L13 and @pd<20030331  | 1                | <u>L14</u>      |
| <u>L13</u>   | L12 and l5  | 5                | <u>L13</u>      |
| <u>L12</u>   | L11 and l1 and l2 and l3  | 135              | <u>L12</u>      |
| <u>L11</u>   | passivation layer near4 mask  | 1038             | <u>L11</u>      |
| <u>L10</u>   | L9 and passivation layer near4 mask   | 0                | <u>L10</u>      |
| <u>L9</u>  | L8 and @pd<20030331   | 21               | <u>L9</u>       |
| <u>L8</u>  | l4 and L7   | 52               | <u>L8</u>       |
| <u>L7</u>  | four photomask  | 116              | <u>L7</u>       |
| <u>L6</u>  | l4 and L5   | 62               | <u>L6</u>       |
| <u>L5</u>  | four near3 photomask  | 278              | <u>L5</u>       |
| <u>L4</u>  | l1 and L3   | 4702             | <u>L4</u>       |
| <u>L3</u>  | (pattern or patterning or patterned) same l2 same pixel   | 6093             | <u>L3</u>       |
| <u>L2</u>  | (transparent near3 (electrode or metal)) or indium tin oxide or ITO or indium zinc oxide or IZO | 473084           | <u>L2</u>       |
| <u>L1</u>  | thin film transistor or tft   | 93736            | <u>L1</u>       |

END OF SEARCH HISTORY

2-22-05  
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